



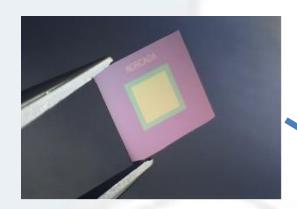
# EUV Pellicle Development via Accelerated Neutral Atom Beam (ANAB) Processing of Ultra-thin Membranes

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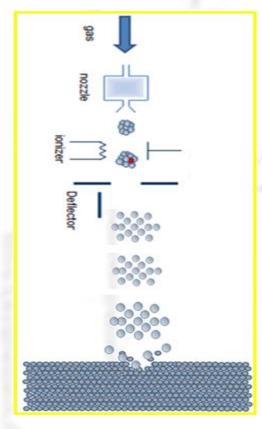
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### **Development Road Map**



Norcada membrane fabrication

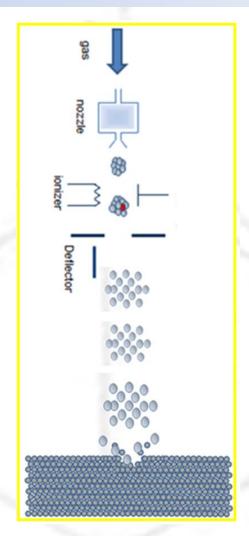


**Exogenesis ANAB Processing** 

**EUV Testing and Evaluation** 

## Accelerated Neutral Atom Beam Technology (ANAB)

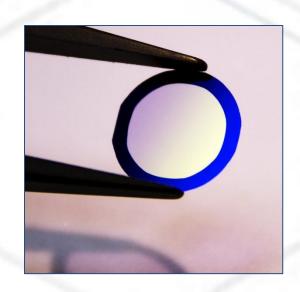
- Unique Accelerated Particle Beam
- Nanoscale Surface Modification
- High Intensity Flux
- Low Energy Particles (10-100+ eV)
- Electrically Neutral
- Surface Penetration ≤ 3 nm





### Norcada Membrane Technology

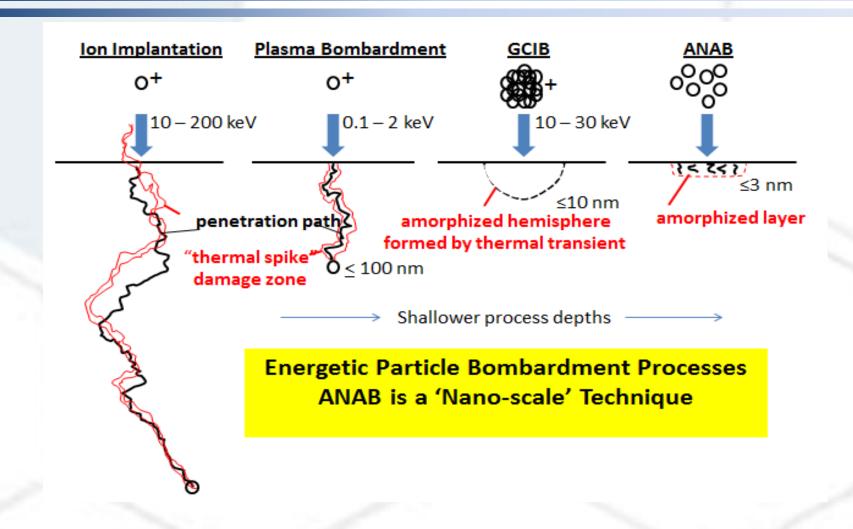
- Norcada is a MEMS and nanotechnology manufacturer in Edmonton, Canada
- Norcada has 'state of the art' manufacturing cleanroom facilities.
- Norcada offers ultrathin membranes for a variety of applications in industrial and scientific fields:
  - Poly and single crystal Silicon membranes
  - Silicon Nitride membranes
  - Metal oxide and nitride membranes
  - Polymeric membranes
  - Multilayer membranes with semiconductor materials and polymeric layers
  - Thin film semi-holey or holey features
  - Dual thickness membranes
  - Free standing carbon membranes



### **Exogenesis ANAB**

- Exogenesis is a nanotechnology company in Billerica, MA USA.
- Exogenesis developed ANAB for surface modifications including:
  - Nanoscale smoothing for reduced EUV scatter
  - Controlled thinning for increased transparency
  - Doping for improved high temperature performance
  - Cleaning / surface preparation / coating interfaces
  - Uniformity correction for production / scaling
- Why is ANAB suited to processing of fragile pellicle materials?
  - ANAB requires no target neutralization
  - ANAB does not apply mechanical forces during processing
  - ANAB is a 'dry' process
  - ANAB is limited to < 3nm process depth NANOSCALE!</p>

### Semiconductor Fabrication Technologies Progression Toward Nano-depth Processing



# EUV %T Increased By ANAB Modification of Silicon and Polysilicon Membranes

Test Group	Sample ID	Part Number	Description		Quantity	Transmission @13.5 nm
1	ALP320140908A	SQ7300C	3mm X 3mm single crystal silicon membrane approx. 100nm thick	Control	1	82.2%
			silicon frame = 7.5 X 7.5mm			
1	ALP320140908B	SQ7300C	3mm X 3mm single crystal silicon membrane approx. 100nm thick	ANAB	1	90.5%
			silicon frame = 7.5 X 7.5mm	Treated		

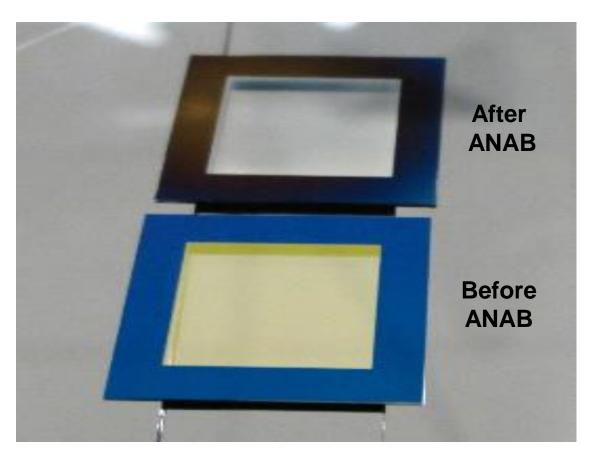
### Single crystal silicon membrane thinned from 100nm to 25nm %T at 13.5nm increased from 82.2% to 90.5%

Test Group	Sample ID	Part Number	Description		Quantity	Transmission @13.5 nm
2	ALP320140908C	PSM5200A	2mm X 2mm polysilicon membrane approx. 50nm thick	Control	1	90.9%
			silicon frame = 5.0 X 5.0mm			
2	ALP320140908D	PSM5200A	2mm X 2mm polysilicon membrane approx. 50nm thick	ANAB	1	94.4%
			silicon frame = 5.0 X 5.0mm	Treated		

Norcada Polycrystalline silicon membrane thinned from 50nm to 25nm %T at 13.5nm increased from 90.9% to 94.4%

<sup>\*</sup>Presented at TWG San Jose 2/28/2015

#### **ANAB Enhanced Membranes**



**Norcada Silicon Nitride Membrane Modified With ANAB** 

### **Pellicle Development Timeline**

- Exogenesis and Norcada have demonstrated 'proof of performance' in multiple studies.
- Full capabilities to develop and produce final product.
- Focused development not yet been initiated.
- Focused development is contingent on funding.
- Scaling to size will require 12-18 months with funding.
- If development begins before end of 2015, production of actual pellicles would be feasible for mid 2017.

#### Thank You!